

GAU/1765  
#8/B  
2/1/02



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant )  
Hirohisa KIKUYAMA et al. ) Art Group: 1765  
Serial No.: 09/622,397 )  
Filing Date: December 1, 2000 )  
Title: SURFACE TREATING FOR ) Examiner: Kin Chan CHEN  
MICROMACHINING AND METHOD )  
FOR SURFACE TREATMENT )

RESPONSE

Hon. Commissioner of Patents  
Washington, D.C. 20231

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Sir:

Responsive to the Office Action dated December 19, 2001,  
having a due date of January 19, 2002, Applicant hereby submits  
the following election.

REMARKS

Claims 1-19 are pending and subject to election in the  
present application.

With this response, Applicant elects Group I, Claims 1-4 and  
9, drawn to a composition for etching and cleaning without  
5 traverse. Please cancel Claims 5-8 and 10-19 without prejudice.